



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerome M. Eldridge et al.

Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW ASYMMETRICAL
TUNNEL BARRIER INTERPOLY INSULATORS

Docket No.: 1303.045US1

Serial No.: 10/081,818

Filed: February 20, 2002

Due Date: December 21, 2006

Examiner: Tu-Tu V. Ho

Group Art Unit: 2818

Customer No.: 21186

Confirmation No.: 3148

Commissioner for Patents

Notice of Allowance Date:

Attn: MAIL STOP ISSUE FEE

September 21, 2006

P.O. Box 1450

Alexandria, VA 22313-1450

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- ☒ Communication Re: Fee Address (1 pg)
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- ☒ Communication Concerning Related Applications (1 pg)
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SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.

Customer Number: 21186

By 

Timothy B. Clise

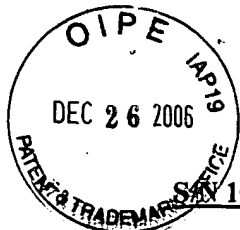
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KATHLEEN E. ROBARCK
Name

Kathleen E. Robarck
Signature



10/081,818

PATENTIN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Jerome M. Eldridge et al. Examiner: Tu-Tu V. Ho
Serial No.: 10/081,818 Group Art Unit: 2818
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Title: ATOMIC LAYER DEPOSITION OF METAL OXIDE AND/OR LOW
ASYMMETRICAL TUNNEL BARRIER INTERPOLY INSULATORS

COMMUNICATION CONCERNING RELATED APPLICATIONS**MS Issue Fee**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Applicants would like to bring to the Examiner's attention the following related applications in the above-identified patent application:

<u>Serial/Patent No.</u>	<u>Filing Date/Issue Date</u>	<u>Attorney Docket</u>	<u>Title</u>
11508090	August 22, 2006	1303.024US4	FLOATING GATE STRUCTURES
11590363	October 31, 2006	1303.014US3	FLASH MEMORY WITH LOW TUNNEL BARRIER INTERPOLY INSULATORS
11565826	December 1, 2006	1303.141US2	HAFNIUM TITANIUM OXIDE FILMS

Continuations and divisionals may be later filed on the cases listed above, or cited to the Examiner in any previous Communication Concerning Related Applications. Applicants request that the Examiner review all continuations and divisionals of the above-listed or previously-cited patent applications before allowing the claims of the present patent application.

Respectfully submitted,

JEROME M. ELDRIDGE ET AL.

By Applicants' Representatives,

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20 Dec '06

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